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facsimile transmittance

To: Examiner Samuel A. Barts
From: Mag Chappuis
E-mail: Mchappuis@atmi.com
Re: Response to July 29, 2003 Office
Action in United States Patent
Application No. 09/811,106

Fax: 703-308-4556
Date: August 12, 2003
Pages: 5
cc:

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Dear Examiner Barts:

Attached is a Response to July 29, 2003 Official Action in U.S. Patent Application No. 09/811,10680 for Low Dielectric Constant Thin Films and Chemical Vapor Deposition Method of Making Same including.

Response: 4 - sheets
Facsimile Transmittal: 1 - sheet

Please call 203-794-1100 ext. 4184 if there are any problems with this transmittal.

Maggie Chappuis

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ATMI Docket: ATM-513

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